

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of	)	Art Unit: 2823
Shunpei YAMAZAKI et al.	)	Examiner: Fernando L. Toledo
Serial No. 09/352,194	)	
Filed: July 13, 1999	)	
For: CRYSTALLINE SEMICONDUCTOR THIN	)	
FILM, METHOD OF FABRICATING THE	)	
SAME, SEMICONDUCTOR DEVICE, AND	)	
METHOD OF FABRICATING THE SAME	)	

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

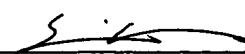
In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The references listed on the attached PTO 1449 Form were cited in related U.S. Application Serial No. 09/352,373.

This Information Disclosure Statement is being submitted with an RCE. Therefore, no fee is required.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280. A duplicate copy of this sheet is attached.

Respectfully submitted,

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